

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE CITATION

In re application of: Jiangtao Wang et al.

Serial No: 10/074,988 Group No.: 2824

Filed: February 13, 2002 Examiner: Michael Lebentritt

For: PROCESS FOR MANUFACTURING COPPER
FOIL ON A METAL CARRIER SUBSTRATECommissioner for Patents
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Alexandria, VA 22313-1450

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U.S. Patent Documents

Examiner Initials	Document Number	Date	Name	Class
DM	4,737,446	04/12/1988	Cohen et al.	430/311
DM	4,790,912	12/13/1988	Holtzman et al.	204/15
DM	5,302,494	04/12/1994	Grandmont et al.	430/325
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DM	6,270,889	08/07/2001	Kataoka et al.	428/352
DM	6,322,904	11/27/2001	Dobashi et al.	428/624

Other Prior Art (Inc. Author, Title, Date, Pertinent Pages, Etc.)

<u>Examiner Initials</u>	<u>Document</u>
<u>DM</u>	U.S. Patent Application Publication No. 2001/0019780, publication date, September 6, 2001, Obata et al., entitled: METAL FOIL WITH CARRIER AND METHOD FOR MANUFACTURING THE SAME.
<u>DM</u>	U.S. Patent Application Publication No. 2003/0029730, publication date, February 13, 2003, Lee et al., entitled: COPPER ON INVAR[00ab] COMPOSITE.

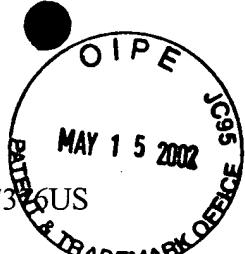
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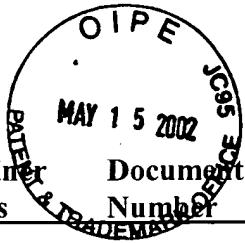
In re application of: Jiangtao Wang et al.

Serial No: 10/074,988 Group No.: 2812
 Filed: February 13, 2002 Examiner: Unknown
 For: PROCESS FOR MANUFACTURING COPPER FOIL ON
 A METAL CARRIER SUBSTRATE

Assistant Commissioner for Patents
 Washington, DC 20231

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DM	6,248,401	06/19/01	Chiang et al.	427/255.7
DM	6,346,335	02/12/02	Chen et al.	428/629

Foreign Patent Documents

Examiner Initials	Document Number	Country	Class	Translation (Yes/No)
DM	EP0872301	Europe	B23K20/10	Yes

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